

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

Applicant: **Bernhard BEIER et al.**  
Application No.: 09/879,609  
Patent No.: **6,784,912 B2**  
Attorney Docket: 600.1161  
Filing Date: June 12, 2001  
Issue Date: August 31, 2004  
Title: **COMPACT MULTIBEAM LASER LIGHT SOURCE AND  
INTERLEAVING RASTER SCAN LINE METHOD FOR  
EXPOSING PRINTING PLATES**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 24, 2011

**CITATION OF PRIOR ART IN A PATENT UNDER 37 C.F.R. 1.501**

Sir:

In accordance with the provisions of 37 C.F.R. 1.501, Applicant hereby cites the documents listed on the accompanying PTO/SB/42 Form (1 pg) for record in the patent file. While the references are being submitted herewith, some or all of the references may not constitute prior art under the U.S. patent laws.

All references were made of record by the Japan Patent Office in Japan Patent Application 2001-200491, which is for an invention related to that of the present patent.

This Information Disclosure Citation in a Patent is filed under 37 C.F.R. 1.501. No fee is believed due. In the event any fee is due in connection with this response the deficiency should be charged to our Deposit Account No. 50-0552.

It is respectfully requested that the references cited in the accompanying PTO/SB/42 Form be made of record in the patent file.

Respectfully submitted,

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